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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Jack O. Chu, et al.

Examiner:

E.J. Kielin

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**Art Unit:** 

2813

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For: LAYER TRANSFER OF LOW DEFECT

SIGE USING AN ETCH-BACK PROCESS

Dated: December 1, 2003

Commissioner for Patents Alexandria, VA 22313-1450

## RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

In response to the Office Action dated July 31, 2003, applicants submit the following amendments and remarks for entry of record in the above-identified patent application.

## **CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box 1450, Alexandria, VA 22313-1450 on December 1, 2003

Dated: December 1, 2003

Susan Formicola

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